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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/720,838	11/24/2003	Mickael Gros-Jean	02-GR1-323	3616
23334 75	590 11/22/2006		EXAMINER	
FLEIT, KAIN, GIBBONS, GUTMAN, BONGINI			CHEN, BRET P	
& BIANCO P.I	L. OMMERCE CENTER		ART UNIT	PAPER NUMBER
551 NORTHWEST 77TH STREET, SUITE 111			1762	
BOCA RATON, FL 33487		DATE MAILED: 11/22/2006		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)					
Office A -41 Commence	10/720,838	GROS-JEAN ET AL.					
Office Action Summary	Examiner	Art Unit					
	B. Chen	1762					
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with t	the correspondence address					
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING D. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period in Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICA 36(a). In no event, however, may a reply will apply and will expire SIX (6) MONTHS a, cause the application to become ABAND	FION. be timely filed from the mailing date of this communication. DONED (35 U.S.C. § 133).					
Status							
_	antambar 2006						
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closed in accordance with the practice under E							
olosed in accordance with the practice under z	-x parte Quayle, 1935 C.D. 1	1, 433 O.G. 213.					
Disposition of Claims							
4)⊠ Claim(s) <u>1-15 and 40</u> is/are pending in the app	olication.						
4a) Of the above claim(s) is/are withdraw	wn from consideration.						
5) Claim(s) is/are allowed.							
6)⊠ Claim(s) <u>1-15 and 40</u> is/are rejected.)⊠ Claim(s) <u>1-15 and 40</u> is/are rejected.						
7) Claim(s) is/are objected to.)☐ Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/o	r election requirement.	•					
Application Papers							
9) The specification is objected to by the Examine	er.						
10) The drawing(s) filed on is/are: a) acc		the Examiner.					
Applicant may not request that any objection to the							
Replacement drawing sheet(s) including the correct		• •					
11)☐ The oath or declaration is objected to by the Ex		* *					
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. & 11	9(a)-(d) or (f)					
a) ☐ All b) ☐ Some * c) ☐ None of:	priority ariaor 00 0.0.0. 3 11	o(a) (a) or (i).					
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3. Copies of the certified copies of the prior							
application from the International Bureau		errea in ano ricaiona. Ciago					
* See the attached detailed Office action for a list	· · · · · · · · · · · · · · · · · · ·	eived.					
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Attachment(s)							
Notice of References Cited (PTO-892)	4) Interview Sumr	nary (PTO-413)					
?) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Ma	ail Date					
)	5)	nal Patent Application					
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DETAILED ACTION

Claims 1-15, 40 are pending in this application. Amended claims 7, 12 and newly added claim 40 are noted.

The amendment dated 9/7/06 has been entered and carefully considered. The examiner appreciates the amendments to the claims. In view of said amendment, the 112 rejection has been withdrawn.

Claim Rejections - 35 USC § 103

The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claims 1-15, 40 are rejected under 35 U.S.C. 103(a) as being unpatentable over

Chiu. Chiu teaches a metal-organic CVD deposition of tantalum oxide using oxygen and

TBTDET (tert-butylimidotris(diethylamido)tantalum). However, the reference fails to teach a carrier material.

It is noted that the reference is directed to a MOCVD process which implies that a substrate was utilized. It is the examiner's position that the carrier material is merely a substrate.

In addition, the reference fails to teach a specific temperature. Temperature is a well known deposition parameter in the CVD art with higher temperatures having the advantage of higher throughput but higher probability of damage from the increased thermal budget. It is well settled that determination of optimum values of cause effective variables such as these process parameters is within the skill of one practicing in the art.

The limitations of claims 2-25, 40 have been addressed above.

Art Unit: 1762

Response to Arguments

Applicant's arguments with respect to the claims have been considered but are moot in view of the new ground(s) of rejection.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to B. Chen whose telephone number is (571) 272-1417. The examiner can normally be reached on 7:30am - 4:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Timothy Meeks can be reached on (571) 272-1423. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Bc 11/20/06

BRET CHEN
PRIMARY EXAMINER